

SPACERS MOUNTING STRUCTURE AND METHOD FOR A FIELD EMISSION DISPLAY

BACKGROUND OF THE INVENTION

5 1. Field of the Invention

The present invention relates to spacers mounting structure and method for a field emission display. By using the clipping arm designed for the spacers and the CCD for real time monitoring, the cross-shaped or
10 rectangle-shaped spacers will be mounted in the field emission display unit for supporting the display.

2. Description of the Prior Art

As digital technology is advancing and the internet
15 is popular, the application of plane display are varied from portable consumer products to large-scale panel for information advertisement, even the very large-scale panel for video communication. Therefore, the general cathode ray displays are not sufficient for these
20 applications. As the plasma display panels (PDP) with a large area and capable of emitting light automatically are merchandized and produced in a mass scale in the recent years, the technology for developing the plane displays with low cost and large area is advanced in a surprising

speed. Now, the tendency is to develop the technology for the mass production of the field emission displays. Therefore, the material fields for the liquid crystal displays and the field emission displays will have more
5 developments as the related technology advances. The materials are developed to be compound, light, thin, large, flexible, and low costing so as to promote the competition ability for the liquid crystal display and field emission display industry.

10 In the prior art field emission display, there are different ways to position the supporting spacers. However, there are some drawbacks in the mounting of the prior art supporting spacers. Please refer to Fig.1. Fig. 1 is a perspective diagram of a prior art field
15 emission display unit. The field emission display comprises a plurality of field emission display units 1, and each of the field emission display units 1 comprises a lower plate 10 and an upper plate 30. And a supporting spacer 20 is mounted between them for division fixing
20 and supporting. As shown in Fig.1, each of the field emission display units 1 comprises three cathode emitters 60 and three light-emitting sources 70. A cathode electrode 50 is used as a base for each of the cathode emitters 60, and the third electrode and dielectric layer

device 40 is used for avoiding shorting with cathode electrodes and pulling up the electrons of the cathode emitters 60. When the cathode emitters 60 emit electrons 61 to the light-emitting sources 70, the light-emitting
5 sources will emit the light correspondingly, and by adjusting the color series, the required color lighting points will be obtained so as to form the required color images.

Please refer to Fig.2. Fig.2 is a perspective diagram
10 of a prior art supporting spacers structure. As shown in Fig.2, the prior art supporting device 20 comprises a plurality of openings 21.

Although the supporting spacers employed in the prior art is not limited to the supporting device 20 and
15 the opening 21 is not limited to be rectangle, in the practical application, the characteristics of the vacuum elements have to be considered when employing the supporting spacers of the field emission display so as to maintain a high air conductivity or the strength for
20 resisting the atmosphere pressure. Therefore, a supporting spacer with a greater width-height ratio has to be obtained without affecting the frame quality of the display. This makes the employed supporting spacers in the prior art can not achieve the requirement of high

resolution.

Furthermore, in the prior art supporting spacers, a mechanical arm or a clipping claw is used as the clipping portion, and this will cause the damages of the supporting spacers because of the mechanical stress.

In the prior art, a mechanical clipping device is employed in the positioning and position-aligning, and the area of the supporting spacer is excessively large. Therefore, the requirement of more precise field emission display cannot be achieved.

SUMMARY OF THE INVENTION

In order to resolve the drawbacks of the prior art, the present invention provides a supporting spacer mounting structure and method for a field emission display so as to overcome the obstacles of the technology development in the prior art. By using a cross-shaped supporting spacer or a rectangle supporting spacer structure, and mounting a supporting spacer by the vacuum absorption of a clipping arm, and using a monitoring lens for a real time monitoring, the operation of embedding the supporting spacers into the field emission display unit is accomplished.

The height of the cross-shaped or rectangle-shaped

supporting spacers used in the present invention is about 0.1 centimeters, and the length of the extended arm is about 0.1 centimeters while the thickness is about 100 micrometer. Therefore, the preciseness is sufficient to
5 achieve the requirement of high resolution for the field emission display. The employed material is glass, ceramics or metal so that the hardness of the material is capable of satisfying the need for supporting the field emission display. Besides, a clipping arm having a
10 positioning slot is used as a mounting structure, and therefore, when performing the operation of positioning the supporting spacer, one arm of the supporting spacer is embedded into the positioning slot and then adsorption opening on the clipping arm will absorb the supporting
15 spacer so as to move the spacer to the required position for mounting.

Furthermore, a monitoring lens is used for monitoring the entire process of the operation so that the supporting spacer can be precisely positioned in the unit
20 of the field emission display.

BRIEF DESCRIPTION OF THE DRAWINGS

The accompanying drawings, which are incorporated in and form part of the specification in which like

numerals designate like parts, illustrate preferred embodiments of the present invention and together with the description, serve to explain the principles of the invention. In the drawings:

5 Fig. 1 is a perspective diagram of a prior art field emission display unit;

 Fig.2 is a perspective diagram of a prior art supporting spacer structure;

 Fig.3 is a perspective diagram of a supporting
10 spacer structure according to an embodiment of the present invention;

 Fig.4 is a perspective diagram of a mounting structure according to an embodiment of the present invention;

15 Fig.5 is a flowchart of the steps operated in the embodiment of the present invention.

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENT

20 Please refer to Fig.3. Fig.3 is a perspective diagram of a supporting spacer structure according to an embodiment of the present invention. As shown in Fig.3, a supporting spacer 20 is cross-shaped. This supporting spacer 20 comprises a supporting unit 22 with a
25 rectangle-shaped structure, and two clipping units 21 are

extended from the middle place of the supporting unit 22.
The height of the supporting spacer 20 is about 0.08~0.1
centimeters, the length of the two extended clipping units
21 is about 0.06~0.2 centimeters and the thickness is
5 about 50~100 micrometers. Therefore, the preciseness is
sufficient to achieve the requirement of high resolution
for the field emission display, and the employed material
is glass, ceramics or metal so that the hardness of the
material is capable of satisfying the need for supporting
10 the field emission display.

Please refer to Fig.4. Fig.4 is a perspective diagram
of a mounting structure according to an embodiment of
the present invention. A clipping arm 23 having a
positioning slot 25 is used as a pre-aligner structure with
15 a spacer, and therefore, when performing the operation of
positioning the supporting spacer 20, one clipping unit
21 of the supporting spacer 20 is embedded into the
positioning slot 25. Furthermore, the clipping arm 23
comprises a plurality of adsorption openings 24 which are
20 installed on the same side surface of the positioning slot
25. Thus, when the operation of absorbing the supporting
spacer 20 by using the clipping arm 23 is performed, the
plurality of the adsorption openings 24 on the clipping
arm 23 and on the same side surface of the positioning

slot 25 will absorb the supporting spacer 20 and move it to the required position in each of the display units of the field emission display.

In addition, in the present invention, a CCD lens 2
5 composed of charge coupling elements is employed for real time monitoring when the clipping arm 23 is moving and positioning the supporting spacer 20. Therefore, the precise position-aligning can be achieved when the clipping arm 23 positioning the supporting spacer 20.
10 Besides, a pre-position-aligning function can be obtained for making the operation more precise and efficient.

Please refer to Fig.5. Fig.5 is a flowchart of the steps operated in the embodiment of the present invention. When the clipping arm performs the operation of
15 positioning the supporting spacer, after the starting (step 51), the clipping arm 52 will be initiated (step 52) and the vacuum process will be performed on the adsorption openings of the clipping arm, and the clipping arm will be moved. Then, in the step 53, the monitoring lens 53 is
20 initiated for monitoring the process of positioning the supporting spacer by the clipping arm. When the clipping arm absorbs the supporting spacer 54 in the step 54, the supporting spacer is embedded into the positioning slot and the plurality of the adsorption openings on the same

side surface will absorb the supporting spacer. Then,
when the clipping arm moves the supporting spacer and
puts it into each of the field emission display units 55
(step 55), the monitoring lens will monitor the entire
5 process of precise positioning so as to accomplish the
operation of positioning the supporting spacer (step 56).
For the design of preliminary position-aligning slot, the
clipping arm does not have to perform the
position-aligning of the rotation angle during the
10 operation of positioning.

The above is the description of the supporting
spacer clipping structure for the field emission display
according to the present invention. In the practical
application, the inventive supporting spacer is a
15 rectangle-shaped structure or a " " structure where an
extending arm is installed on the rectangle-shaped
structure to be clipped by the clipping arm for
positioning. In addition, because the clipping arm clips
the supporting spacer by the plurality of absorption
20 openings, and the absorption openings absorb the
supporting spacer by vacuum-absorption. Therefore,
compared with the prior art, the supporting spacer will
not be damaged by the mechanical stress. Because one
field emission display has many field emission display

units, the monitoring lens of the invention further performs a process of pre-position-aligning so as to promote the efficiency of positioning supporting spacer, and the monitoring lens will monitor the entire process so
5 as to make it efficient to position the supporting spacer in the required place.

Those skilled in the art will readily observe that numerous modifications and alterations of the device may be made while retaining the teachings of the invention.
10 Accordingly, the above disclosure should be construed as limited only by the metes and bounds of the appended claims.